



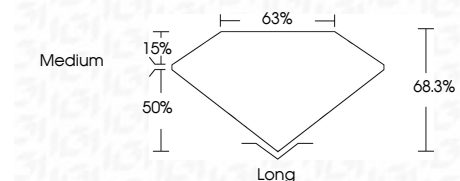
ELECTRONIC COPY

LG662412216
Report verification at igi.org



October 23, 2024
IGI Report Number **LG662412216**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **9.58 X 6.84 X 4.67 MM**

GRADING RESULTS
Carat Weight **3.04 CARATS**
Color Grade **D**
Clarity Grade **VS 1**



ADDITIONAL GRADING INFORMATION
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG662412216**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



October 23, 2024
IGI Report No. LG662412216
EMERALD CUT
9.58 X 6.84 X 4.67 MM
3.04 CARATS
D
VS 1
68.3%
50%
Medium
Long
EXCELLENT
EXCELLENT
NONE
IGI LG662412216
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LABORATORY GROWN DIAMOND REPORT

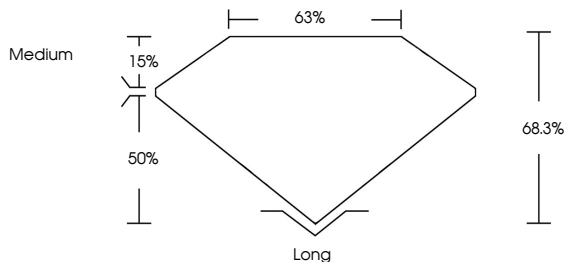
October 23, 2024
IGI Report Number **LG662412216**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **EMERALD CUT**
Measurements **9.58 X 6.84 X 4.67 MM**

GRADING RESULTS
Carat Weight **3.04 CARATS**
Color Grade **D**
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG662412216**

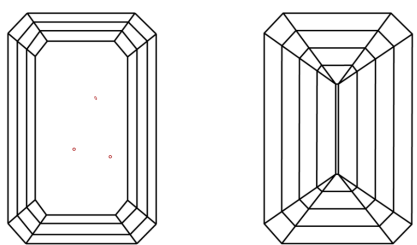
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



October 23, 2024
IGI Report No. LG662412216
EMERALD CUT
9.58 X 6.84 X 4.67 MM
3.04 CARATS
D
VS 1
68.3%
50%
Medium
Long
EXCELLENT
EXCELLENT
NONE
IGI LG662412216
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa